

Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i>		Docket Number (Optional) 2919.1US (96-0499.01)	Application Number 09/ To be assigned 072905
		Applicant Pai-Hung Pan	
		Filing Date May 5, 1998	Group Art Unit <u>To be assigned</u> 2823

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	NAME	DATE	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
G	4,786,954	Morie et al.	11/22/88	—	—	
G	4,849,344	Desbiens et al.	07/18/89	—	—	
G	5,173,439	Dash et al.	12/22/92	—	—	
G	5,272,117	Roth et al.	12/21/93	—	—	
G	5,296,392	Grula et al.	03/22/94	—	—	
G	5,297,082	Lee	03/22/94	—	—	
G	5,346,587	Doan et al.	09/13/94	—	—	
G	5,433,794	Fazan et al.	07/18/95	—	—	
G	5,436,488	Poon et al.	07/25/95	—	—	
G	5,459,096	Venkatesan et al.	10/17/95	—	—	
G	5,492,858	Bose et al.	02/20/96	—	—	
G	5,516,625	McNamara et al.	05/14/96	—	—	
G	5,516,721	Galli et al.	05/14/96	—	—	
G	5,521,422	Mandelman et al.	05/28/96	—	—	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

	Davari, et al., "A Variable-Size Shallow Trench Isolation (STI) Technology With Diffused Sidewall Doping For Submicron CMOS", <i>IEEE IEDM</i> (1988).
	K. Blumenstock et al., "Shallow Trench Isolation for Ultra-Large-Scale Integrated Devices", <i>J. Vac. Sci. Technol.</i> , B 12(1) (Jan/Feb 1994).

EXAMINER	DATE CONSIDERED
<i>Ferguson</i>	<i>11/7/99</i>

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

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		Applicant Pai-Hung Pan	
		Filing Date May 5, 1998	Group Art Unit 2811 2823

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS

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